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Attorney Docket No.: 0492611-0543/MIT-9277CON 1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Seleznev, *et al.* Examiner: Cooke

Serial No.: 10/799,436 Art Unit: 1751

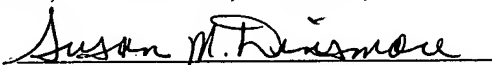
Filing Date: March 12, 2004

Title: VACUUM PROCESSING FOR FABRICATION OF  
SUPERCONDUCTING THIN FILMS FABRICATED BY METAL-  
ORGANIC PROCESSING

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on September 22, 2005

  
Susan M. Dinsmore

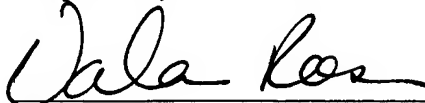
**TRANSMITTAL**

Enclosed herewith please find:

1. Office Action Response Under 37 C.F.R. §1.111 (8 pgs.);
2. Terminal Disclaimer (2 pgs.);
3. Petition for Extension of Time Under 37 C.F.R. §1.136;
4. Declaration of Michael J. Cima Under 37 C.F.R. §1.132 (including Exhibits 1 and 2) (30 pgs.);
5. Declaration of Michael J. Cima Under 37 C.F.R. §1.131 (including Exhibit 1) (8 pgs.);
6. Declaration of Valarie B. Rosen Under 37 C.F.R. §1.132 (including Exhibits A and B) (5 pgs.);
7. Check in the amount of \$130.00 for the Terminal Disclaimer surcharge;
8. Check in the amount of \$1,020.00 for the extension surcharge; and
9. Return postcard.

Please charge any fees associated with this filing, or apply any credits, to our Deposit Account No. 03-1721.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Vala Rosen", written over a horizontal line.

Valarie B. Rosen

Registration No.: 45,698

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Dated: September 22, 2005

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